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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\*

NONE  
CME

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN P2002-317028 10/31/2002

CME

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 57	TOTAL CLAIMS 15	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged  Examiner's Signature: <i>C. Hueskask</i> Initials: _____				

## ADDRESS

181  
 MILES & STOCKBRIDGE PC  
 1751 PINNACLE DRIVE  
 SUITE 500  
 MCLEAN, VA  
 22102-3833

## TITLE

Method for fabricating semiconductor devices

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees
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